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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Huang, et al.

Serial No.: 10/765,361

Filed: January 27, 2004

For: Method for Depositing Low  
K Films

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Group Art Unit: Unknown

Examiner: Unknown

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING	
37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>12/7</u> , 2004 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
<u>12/7/04</u> Date	<u>Keith M. Tackett</u> Signature

Dear Sir:

STATUS INQUIRY

More than 10 months have passed since

☒ the filing of this application on January 27, 2004.

☐ the filing of applicant's response on .

No communication has been received from the Patent and Trademark Office indicating action on this application.

Kindly advise the undersigned of the present status of this application. A stamped return-addressed envelope is provided.

Respectfully submitted,

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